

## Refine Search

### Search Results -

Terms	Documents
semiconductor and ((handle adj wafer) same TMAH)	13

Database:

US Pre-Grant Publication Full-Text Database
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Search:






### Search History

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	<i>DB=USPT; PLUR=YES; OP=ADJ</i>		
<u>L8</u>	semiconductor and ((handle adj wafer) same TMAH)	13	<u>L8</u>
<u>L7</u>	semiconductor and (anodic adj bond\$) and ((handle adj wafer) same TMAH)	0	<u>L7</u>
<u>L6</u>	semiconductor and ((anodic adj bond\$) same (pressure or atmosphere)) and ((handle adj wafer) same TMAH)	0	<u>L6</u>
<u>L5</u>	semiconductor and ((anodic adj bond\$) same (pressure or atmosphere)) and (handle adj wafer)	11	<u>L5</u>
<u>L4</u>	semiconductor and ((anodic adj bond\$) same (pressure or atmosphere))	295	<u>L4</u>
<u>L3</u>	3922705.pn.	1	<u>L3</u>
<u>L2</u>	4079508	26	<u>L2</u>
<u>L1</u>	6077721	5	<u>L1</u>

END OF SEARCH HISTORY